

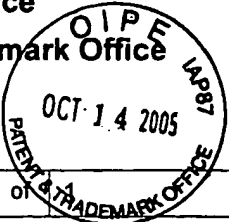


Application Number	10/038,745
Filing Date	01/02/2002
First Named Inventor	Robert Jackson
Group Art Unit	1754
Examiner Name	Nguyen, Ngoc Yen M
Attorney Docket Number	FOC1100-1

Sheet	1	OF	1
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U.S. PATENT DOCUMENTS

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FORM PTO 1449 US Department of Commerce Patent and Trademark Office 		Application Number	10/038,745	
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Sheet 1	of 1	Atty Docket Number	FOC1100-1	
Examiner Initials	Cite No.	OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS		Date
<i>ngm</i>	C17	Mickelson, et al., "Fluorination of Single-Wall Carbon Nanotubes," <i>Chemical Physics Letters</i> 296," pgs. 188-194.		10/30/1998
<i> </i>	C18	Foon and Kaufman, Kinetics of Gaseous Fluorine Reactions, <i>Progress in Reaction Kinetics</i> , Vol. 8, No. 2, pp. 81-93		1975
<i>ngm</i>	C19	C.J. McGab, VLSI Technology, Section 8.3-Dry Etching, McGraw Hill Book Co., pp. 312-317		1983
Examiner Signature	<i>Ngoc-yen Nguyen</i>		Date Considered	<i>1/6/06</i>